



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Makoto INAI, et al.

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Assistant Commissioner for Patents

Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same

for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on May 10, 2001:

Martin Pfeffer

Name of applicant, assignee Registered Representative

May 10, 2001

Date of Signature

Respectfully submitted,

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MP:jy Enclosures